

00684.003654

PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TAKAKO YAMAGUCHI ET AL.

Application No.: 10/529,891

Entry into U.S. National

Stage Under 35 U.S.C. § 371: April 1, 2005

For: EXPOSURE MASK, METHOD OF DESIGNING:

AND MANUFACTURING THE SAME,

EXPOSURE METHOD AND APPARATUS,

PATTERN FORMING METHOD, AND DEVICE)

MANUFACTURING METHOD

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: Examiner: Unassigned

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: Group Art Unit: 1756

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: June 22, 2005

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to examination on the merits, please amend the above-identified application as follows: